



11/C/E07 (3)
12-10-02
D. BEI
RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2881

PATENT
Docket No.: 29284/541

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: NARA, Yasuhiko et al.

SERIAL NO. : 09/832,220

FILED : April 11, 2001

FOR : INSPECTION METHOD, APPARATUS AND SYSTEM FOR
CIRCUIT PATTERN

ART UNIT : 2881

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EXAMINER Jack I. Berman

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ASSISTANT COMMISSIONER
FOR PATENTS
Washington, DC 20231

AMENDMENT

SIR:

In response to the Office Action of May 30, 2002, the period for response having been extended herein to December 2, 2002 (November 30th falls on a Saturday) by payment of the requisite fee of \$920.00 for a Petition for Extension of Time Under 37 C.F.R. § 1.136(a), Applicants respectfully request that the following amendment be entered to place this application in condition for allowance or better form for appeal.

IN THE CLAIMS:

Amend the claims 2, 3 and 4 as indicated below:

2. (Amended) An inspection apparatus for a circuit pattern, comprising:

C1
Sub
D1